

DOCKET NO: 284901US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
HACHISHIRO IIZUKA : EXAMINER: CHEN, KEATH T.
SERIAL NO: 10/565,676 :
FILED: JANUARY 24, 2006 : GROUP ART UNIT: 1792
FOR: GAS REACTION SYSTEM AND :
SEMICONDUCTOR PROCESSING
APPARATUS

SUPPLEMENTAL AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Supplemental to the Amendment filed February 8, 2008 and in response to the
Advisory Action dated February 25, 2008, please amend the above-identified application as
follows:

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.